

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Eiichi ISHII et al. :  
Serial No. NEW : **Attn: APPLICATION BRANCH**  
Filed September 11, 2003 : Attorney Docket No. 2003-1290  
**METHOD OF SURFACE TREATMENT  
OF TITANIUM METAL** :  
**(Rule 1.53(b) Continuation-in-Part of  
Serial No. 09/902,260, Filed July 11, 2001)**

**CLAIM OF PRIORITY UNDER 35 U.S.C. § 119**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

Sir:


Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2000-211518, filed July 12, 2000, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/902,260, filed July 11, 2001.

Respectfully submitted,

Eiichi ISHII et al.

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